

MAR 05 2001

PTO/SB/30 (5/2000)

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REQUEST FOR CONTINUED EXAMINATION (RCE)

Subsection (b) of 35 U.S.C. §132, effective on May 29, 2000, provides for continued examination of a utility or plant application filed on or after June 8, 1995. See The American Inventors Protection Act of 1999 (AIPA).

Application Number	09/304,523
Filing Date	May 4, 1999
First Named Inventor	Shunpei Yamazaki, et al.
Group Art Unit	1765
Examiner Name	D. Champagne
Attorney Docket Number	07977-046002

This is a Request for Continued Examination (RCE) under 37 C.F.R. §1.114 of the above-identified application.

NOTE: 37 C.F.R. §1.114 is effective on May 29, 2000. If the above-identified application was filed prior to May 29, 2000, applicant may wish to consider filing a continued prosecution application (CPA) under 37 C.F.R. §1.53(d) (PTO/SB/29) instead of a RCE to be eligible for the patent term adjustment provisions of the AIPA. See Changes to Application Examination and Provisional Application Practice, Interim Rule, 65 Fed. Reg. 14865 (Mar. 20, 2000), 1233 Off. Gaz. Pat. Office 47 (Apr. 11, 2000), which established RCE practice.

1. Submission required under 37 C.F.R. §1.114

- a. ☒ Previously submitted
- ☒ Consider the amendment(s)/reply under 37 C.F.R. §1.116 previously filed on November 30, 2000
(Any unentered amendment(s) referred to above will be entered)
 - ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____
 - ☐ Other _____
- b. ☒ Enclosed
- ☒ Amendment/Reply
 - ☐ Affidavit(s)/Declaration(s)
 - ☐ Information Disclosure Statement (IDS)
 - ☐ Other _____


2. Miscellaneous

- a. ☐ Suspension of action on the above-identified application is requested under 37 C.F.R. §1.183(c) for a period of _____ months. (Period of suspension shall not exceed 3 months; fee under 37 C.F.R. §1.17(i) required)
- b. ☐ Other _____

3. Fee The RCE fee under 37 C.F.R. §1.17(e) is required by 37 C.F.R. §1.114 when the RCE is filed.

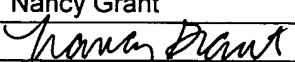
- a. ☒ The Director is hereby authorized to charge the following fees, or credit any overpayments, to Deposit Account No. 06-1050
- ☒ RCE fee required under 37 C.F.R. §1.17(e) 03/06/2001 CVD111 00000085 09304523
 - ☒ Extension of time fee (37 C.F.R. §§1.136 and 1.17) 01 FC:179 710.00 OP
 - ☐ Other _____
- b. ☒ Check in the amount of \$ 1600 enclosed
- c. ☐ Payment by credit card (Form PTO-2038 enclosed)

SIGNATURE OF APPLICANT, ATTORNEY OR AGENT REQUIRED

Name (Print/Type)	Scott C. Harris	Registration No. (Attorney/Agent)	32,030
Signature		Date	2/28/01

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to **Commissioner for Patents, Box RCE, Washington, DC 20231** or facsimile transmitted to the U.S. Patent and Trademark Office on: February 28, 2001

Name (Print/Type)	Nancy Grant	Date	2/28/01
Signature			



#15/f

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al. Art Unit : 1765
Serial No.: 09/304,523 Examiner : D. Champagne
Filed : May 4, 1999
Title : METHOD AND APPARATUS FOR PRODUCING SEMICONDUCTOR DEVICE

BOX RCE

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

In response to the action mailed August 30, 2000, please
amend the application as follows:

In the Claims:

Please amend claims as follows:

7. (Thrice Amended) A method of manufacturing a liquid
crystal display device comprising the steps of:
forming a semiconductor film over a substrate having
an upper surface and a lower surface, wherein said upper surface
is an insulating surface;
flattening said substrate by vacuum-sucking said
substrate onto a stage having a flat surface in such a manner
that said lower surface of said substrate is in contact with
said flat surface of the stage; and
irradiating said semiconductor film with a laser beam
having a cross section which is elongated in one direction while
relatively moving said substrate with respect to said laser beam

CERTIFICATE OF MAILING BY FIRST CLASS MAIL
I hereby certify under 37 CFR §1.8(a) that this
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